

## PATENT APPLICATION

## IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re the Application of

Hiroyuki NAGASAKA

Group Art Unit: 2882

Application No.: 10/584,950

Examiner:

P. KIM

Filed: July 5, 2006

Docket No.: 128620

EXPOSURE APPARATUS, EXPOSURE METHOD, AND DEVICE PRODUCING

**METHOD** 

## <u>AMENDMENT</u>

Commissioner for Patents P.O. Box 1450 Alexandria, VA 22313-1450

Sir:

In reply to the June 10, 2010 Office Action, the period for reply being extended by the attached Petition for Extension of Time, and upon entry of the attached Request for Continued Examination, please consider the following:

Amendments to the Claims as reflected in the listing of claims; and Remarks.